

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Shuji HAHAKURA, et al.  
Title: METHOD OF PRODUCING OXIDE  
SUPERCONDUCTING FILM (As Amended)  
Appl. No.: 10/511,268  
International Filing Date: 4/17/2003  
371(c) Date: 10/20/2004  
Examiner: Brian K. Talbot  
Art Unit: 1792  
Confirmation Number: 6578

**AMENDMENT AND REPLY UNDER 37 CFR 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated February 20, 2008, concerning the above-referenced patent application.

**Amendments to the Title** are reflected in the listing of the claims which begins on page 2 of this document.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this document.

**Remarks/Arguments** begin on page 6 of this document.